	Application No.	Applicant(s)	
Notice of Allowability	10/725,407	TERUNUMA ET AL.	
	Examiner	Art Unit	-
	A. Dexter Tugbang	3729	
The MAILING DATE of this communication apper All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RI of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in this app or other appropriate communication GHTS. This application is subject to	olication. If not include will be mailed in due	ed course. THIS
1. This communication is responsive to <u>Application filed on De</u>	ecember 3, 2003.		
2. The allowed claim(s) is/are 1 and 2.			
 3. Acknowledgment is made of a claim for foreign priority unapplication. a) All b) Some* c) None of the: 1. Certified copies of the priority documents have 2. Certified copies of the priority documents have 3. Copies of the certified copies of the priority documents have International Bureau (PCT Rule 17.2(a)). * Certified copies not received: 	been received. been received in Application No. 09		tion from the
Applicant has THREE MONTHS FROM THE "MAILING DATE" of this communication to file a reply complying with the requirements noted below. Failure to timely comply will result in ABANDONMENT of this application. THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.			
4. A SUBSTITUTE OATH OR DECLARATION must be submit INFORMAL PATENT APPLICATION (PTO-152) which give			IOTICE OF
 CORRECTED DRAWINGS (as "replacement sheets") must (a) including changes required by the Notice of Draftspers 1) hereto or 2) to Paper No./Mail Date (b) including changes required by the attached Examiner's Paper No./Mail Date Identifying indicia such as the application number (see 37 CFR 1. each sheet. Replacement sheet(s) should be labeled as such in the 	on's Patent Drawing Review (PTO-9 s Amendment / Comment or in the O 84(c)) should be written on the drawir	Office action of	e back) of
6. DEPOSIT OF and/or INFORMATION about the deposit attached Examiner's comment regarding REQUIREMENT I			Note the
 Attachment(s) 1. ☑ Notice of References Cited (PTO-892) 2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948) 3. ☑ Information Disclosure Statements (PTO-1449 or PTO/SB/0 Paper No./Mail Date 12/3/03 4. ☐ Examiner's Comment Regarding Requirement for Deposit of Biological Material 	5. Notice of Informal P 6. Interview Summary Paper No./Mail Dat 7. Examiner's Amendn 8. Examiner's Stateme 9. Other	(PTO-413), te nent/Comment	

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EXAMINER'S AMENDMENT

1. An examiner's amendment to the record appears below. Should the changes and/or

additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR

1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the

payment of the issue fee.

The application has been amended as follows.

NOTE: The changes below are minor in nature to merely update the status of the parent

application and to correct informalities with the grammar of the claim language. The changes

below in no way affect the scope of the claimed invention.

In the Specification

In the specification on page 1, the paragraph between the title and the first line of text has

been replaced as follows.

This is a Division of Application No. 09/603,970, filed June 26, 2000, now U.S. Patent

6,678,941. The entire disclosure of the prior application is hereby incorporated by reference

herein in its entirety.

In the Claims

In Claim 1, the phrase of "on the parts" (line 23) has been replaced with –on parts--; and

the phrase of "as a mask" (line 32) has been replaced with –as another mask--.

Reasons for Allowance

2. The following is an examiner's statement of reasons for allowance.

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The prior art does not teach, fairly suggest, or render obvious, all of the limitations of the claimed invention including: forming, in the non-magnetic film, a hollowed hole, exposing the gap film; forming a mask to cover the first and second magnetic films after removing the plate underfilm; and removing parts of the plate film and the plate underfilm not covered by the mask.

The closes prior art reference is directed to Miyauchi et al (U. S. Patent 6,047,462). Miyauchi teaches a process for manufacturing a thin film magnetic head including: forming a non-magnetic film (e.g. 313 in Fig. 7) over a gap film (e.g. 340); forming a first magnetic film (e.g. 312); forming a second magnetic film (e.g. 322); forming frames (e.g. 14); removing the frames; and etching the first magnetic film into a definitive pattern through the second magnetic film used as another mask.

Miyauchi does <u>not</u> teach: forming a hollowed hole in the non-magnetic film; removing any parts of any plate underfilm exposed after removing the frames, forming a mask to cover the first and second magnetic films, removing the parts of any plate film and plate underfilm not covered by the mask.

To modify Miyauchi by adding the missing features above would not be obvious to one of ordinary skill in the art as this would simply destroy the structure of Miyauchi since the magnetic head of Miyauchi does not include any additional layers of at least a plate film and a plate underfilm, or any hollowed hole through the non-magnetic film.

Accordingly, Claims 1 and 2 are allowed.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue

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fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

3. Any inquiry concerning this communication or earlier communications from the examiner should be directed to A. Dexter Tugbang whose telephone number is 571-272-4570. The examiner can normally be reached on Monday - Friday 8:30 am - 5:00 pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Peter Vo can be reached on 571-272-4690. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

A. Dexter Tugbang

Primary Examiner

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March 6, 2006